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APPLICANTS

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** FOREIGN APPLICATIONS *****

JAPAN 2000-112216 04/13/2000

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35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged Examiner's Signature	Initials			

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TITLE

Pipe structure, alignment apparatus, electron beam lithography apparatus, exposure apparatus, exposure apparatus
maintenance method, semiconductor device manufacturing method, and semiconductor manufacturing factory

FILING FEE RECEIVED 1654	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit
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